

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: **John Mize et al.**

Serial No: **10/542040**

Filed: **February 6, 2006**

For: **APPARATUS AND  
METHODS FOR IONIZED  
DEPOSITION OF A FILM  
OR THIN LAYER**

Examiner: **Jason Berman**

Art Unit: **1795**

**RESPONSE TO FINAL OFFICE ACTION**

**MAIL STOP AF  
COMMISSIONER OF PATENTS  
P.O. Box 1450  
ALEXANDRIA, VA 22313-1450**

Dear Sir:

This paper responds to the Office Action dated July 16, 2009. Please enter the following:

**CLAIMS AMENDMENTS:** Begins on Page 2

**SPECIFICATION AMENDMENTS:** None

**FIGURES AMENDMENTS:** None

**REMARKS SECTION:** Begins on Page 6